



# PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

**Kazuyoshi NAMBA**

Serial No.: 09/940,855

Filed: August 29, 2001

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Group Art Unit: 1744

Examiner: M. Spisich

For : SUBSTRATE CLEANING APPARATUS AND SUBSTRATE  
CLEANING METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A response to the Office Action dated September 3, 2003 (Paper No. 8) was due by December 3, 2003. A Petition for Extension of Time (three months, large entity) is enclosed, extending the date to March 3, 2004. Therefore, please accept this Amendment as timely filed.

In response to Paper No. 8, kindly amend the above-identified patent application as set forth below.

03/05/2004 SSESHE1 00000142 09940855  
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